							•		
Subt. For, PTO-1449			Docket Number 109635.150		Application Number 10/004,565				
INFORMATION DISCLOSURE			E						
IN AN APPLICATION				Applicant Albert Perdon					
(Use several sheets if necessary)				' Filing Date Group Art Unit					
Sheet /	1 3		1	December 5,2001		2614			
L	/ ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' '		-			2017			
P	FEB 2 6 2002	')							
EXAMINER	Tr. SE	U.	S. Pate	nt Docume	nts	<u> </u>	*		
COMMITTEE	~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~	DATE		NAME	CLASS	SUBCLASS	FILING		
TPN	NUMBER 6,163,316	12/19/00		Killian			IF APPRO	JPRIATE	
IEN	6,177,931	01/23/01	Δlex	cander et al	<u> </u>	 			
	6,018,372	01/25/00			<u> </u>	-			
	6,305,017	10/16/01		Etheredge Satterfield				····.	
	5,592,551	01/07/97		ett et al.		DEC	EIVE	<u>n</u>	
	6,014,654	01/11/00		Ariyoshi		DEL	/LIVE	U	
 	6,041,311	03/21/00	Chislenko et al.			MAR	0 1 200	17	
	6.049.777	04/11/00	Sheena et al.			1	 		
-	6,064,980	05/16/00	Jacobi et al.		 	Technolo	y Center	2600	
	6,092,049	07/18/00		slenko et al.	 				
	6,119,101	09/12/00	F	Peckover	—				
	6,134,532	10/17/00	La	zarus et al.	,	<u> </u>			
-	6,026,368	02/15/00	Br	own et al.		<u> </u>			
	6,157,946	12/05/00	Ita	kura et al.			-		
-	5,347,632	09/13/94	Filepp et al.						
	5,572,643	11/05/96		Judson					
	5,740,549	04/14/98	Reilly et al.						
	5,754,774	05/19/98	Bitt	inger et al.					
	5,761,662	06/02/98		Dasan				_	
	5,794,210	08/11/98	Gold	ihaber et al.					
	5,812,784	09/22/98	Wa	atson et al.					
	5,913,040	06/15/99	Ra	kavy et al.					
	5,946,646	08/31/99	Sc	hena et al.					
A	5,959,623	09/28/99	Vai	Hoff et al.	<u> </u>				
			oien De	tont Dogum	onto				
EXAMINER	DOCUMENT	DATE		tent Docum	CLASS	SUBCLASS	TRANSLATION		
INITIAL	NUMBER		`				YES	NO	
	WO 00/49801	24.08.2000		WIPO		<u></u>			
		Other F	200:	nto /le-alisali-	a Author Till	la Data Barti	nont Pag	es Eta \	
Other Documents (Including Author, Title, Date Pertinent Pages, Etc.) U.S. Patent Application Publication No. 20010049620									
	J.C. I GOTT PAPIL								
EVALUNCO	77			DATE CONS	SIDEBEN	1			

	ents (Including Author, Title, Date Pertinent Pages, Etc.)
U.S. Patent Application Publication No. 200100	049620
EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation is considered, whether or not citation if not conformance and not considered. Include copy w	citation is in conformance with MPEP § 609: Draw Line through with next communication to applicant.

Subt. For, PTO-1449 INFORMATION DISCLOSURE	Docket Number 109635.150	Application Number 10/004,565	
IN AN APPLICATION	Applicant Albert Perdon		
Ose several sheets if flecessary)	Filing Date	Group Art Unit	
Sheet 1 OF 1	December 5,2001	2614	

DATE

DOCUMENT NUMBER

EXAMINER INITIAL

U.S. Patent Documents

CLASS

SUBCLASS

FILING DATE IF APPROPRIATE

6,411,337 Jun. 25, 2002 Cove et al. Nov. 6, 2001 LaRocca et al RECEIVEL JUN 1 0 2003 Technology Center 26	
JUN 1 0 2003 Technology Center 26]
JUN 1 0 2003 Technology Center 26	
JUN 1 0 2003 Technology Center 26	
Technology Center 26	-
	2000
	2000
Foreign Patent Documents	
EXAMINER DOCUMENT DATE COUNTRY CLASS SUBCLASS TRANSLATION	
INITIAL NUMBER YES NO	<u>-</u>
Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)	tc.)
U.S. Patent Application Publication No. 2002/0049972, Apr. 25, 2002, Kimoto	
	- -
DATE CONSIDERED 2508	
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.	
citation if not conformance and not considered. Include copy with thext confinding about to applicable.	